



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventors: DeOrnellas, et al.

Application No.: 09/692,007

Confirm. No.: 7175

Filed: October 19, 2000

Title: METHOD FOR USING A HARD MASK FOR
CRITICAL DIMENSION GROWTH
CONTAINMENT

PATENT APPLICATION

Art Unit: 1765

Examiner: L. Umez Eronini

Customer No. 23910

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited in the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on December 29, 2004.

(Attorney Signature)

Sheldon R. Meyer, Reg. No. 27,660
Signature Date: December 29, 2004

RESPONSE TO OFFICE ACTION UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed June 30, 2004, please amend the above-identified application as follows.